Ø 001/007

SEP 19 2005

67,124-014; R-05323

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Halwan

SERIAL NO.:

10/736,260

FILED:

12/15/2003

GROUP ART:

3744

EXAMINER:

Jiang, Chen Wen

FOR:

00 to enfect 05 Control Logic for Maintaining Proper Solution Concentration in an

Absorption Chiller in co-Generation Applications

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

Supplemental to the complete response filed August 24, 2005, please amend the aboveidentified application as follows: